Docket No.: 5077-000069/US/DVA

(PATENT)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Kenya Uomori et al.

Application No.: 10/617,198 Confirmation No.: 3517

Filed: July 10, 2003 Art Unit: 2875

For: Range Finder, Three-Dimensional Measuring Examiner: J. Y. Choi Method And Light Source Apparatus

## AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116

MS AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

## INTRODUCTORY COMMENTS

In response to the Office Action dated August 18, 2006, finally rejecting claims 21-22, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 11 of this paper.